

41.

PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q64809

Kenji Matsumoto

Appln. No.: 09/873,218

Group Art Unit: 2828

Confirmation No.: 4028

Examiner: Tuan M. NGUYEN

Filed: June 05, 2001

For: SEMICONDUCTOR LASOR FABRICATING METHOD OF THE SAME

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP NON-FEE AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated September 10, 2003, please amend the above-identified application as follows on the accompanying pages.

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